

FILE COPY *Receipt*

PATENT

#3
[Signature]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Applicant: Jammy et al.
Application No.: 09/363,523
Filed: July 29, 1999

Docket No.: 99 P 7722 US
Group Art Unit: 2811
Examiner: Not Assigned
Date: November 10, 1999

Title: Method For Forming Crystalline Silicon Nitride

Attn: Customer Correction Branch
Application Processing Division

Hon. Assistant Commissioner for Patents
Washington, DC 20231

REQUEST FOR CORRECTION OF FILING RECEIPT

Sir:

The Filing Receipt in the above referenced matter contains a typographical error. Enclosed (Exhibit A) is a copy of the Express Mailing Label in the above matter, on which the date of deposit is shown to be **July 29, 1999**. The Filing Receipt, however, states the filing date incorrectly as **July 28, 1999**. The **boldface** text shows the location of the typographical error.

Enclosed (Exhibit B) is a copy of the Filing Receipt upon which the necessary changes have been noted.

Issuance of a corrected Filing Receipt is respectfully solicited. It is believed that no fee is due for this Request. However, if such a fee is due, please charge it to Deposit Account No. 19-2179.

Respectfully submitted,

Donald B. Paschburg

Donald B. Paschburg, Esq.
Reg. No. 33,753

Dated: November 10, 1999

Siemens Corporation
Intellectual Property Department
186 Wood Avenue South
Iselin, New Jersey 08830
(732) 321-3191

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TC 2000 MAIL ROOM

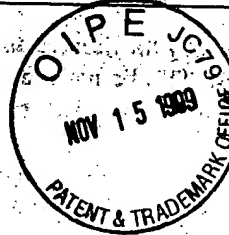
FILING RECEIPT



UNITED STATES DEPARTMENT OF COMMERCE
Patent and Trademark Office
ASSISTANT SECRETARY AND COMMISSIONER
OF PATENTS AND TRADEMARKS
Washington, D.C. 20231

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTORNEY DOCKET NO.	DRWGS	TOT CL	IND CL
09/363,523	07/28/99	2811	\$760.00	99-P-7722-US	5	20	3

SIEMENS CORPORATION
INTELLECTUAL PROPERTY DEPARTMENT
186 WOOD AVENUE SOUTH
ISELIN NJ 08830



Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts of Application" ("Missing Parts Notice") in this application, please submit any corrections to this Filing Receipt with your reply to the "Missing Parts Notice." When the PTO processes the reply to the "Missing Parts Notice," the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s) RAJARAO JAMMY, WAPPINGERS FALLS, NY; PHILIP L. FLAITSZ,
NEWBURGH, NY; PHILIP E. BATSON, KATONAH, NY; HUA SHEN,
BEACON, NY; YUN YU WANG, POUGHQUAG, NY.

IF REQUIRED, FOREIGN FILING LICENSE GRANTED 08/25/99
TITLE
METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE

PRELIMINARY CLASS: 257

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(Exhibit B)

DATA ENTRY BY: GARNETT, SANDRA

TEAM: 06 DATE: 08/25/99

(See reverse for more information)

SERIAL NUMBER	FILING DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
09/363,523	07/29/99	257	2815	99-P-7722-US

APPLICANT RAJARAO JAMMY, WAPPINGERS FALLS, NY; PHILIP L. FLAITSZ, NEWBURGH, NY;
PHILIP E. BATSON, KATONAH, NY; HUA SHEN, BEACON, NY; YUN YU WANG,
POUGHQUAG, NY.

CONTINUING DOMESTIC DATA***
VERIFIED

EO *None*

371 (NAT'L STAGE) DATA***
VERIFIED

EO *None*

FOREIGN APPLICATIONS***
VERIFIED

EO *None*

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TC 2000 HALL ROOM

IF REQUIRED, FOREIGN FILING LICENSE GRANTED 08/25/99

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY NY	SHEETS DRAWING 5	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
Verified and Acknowledged <u>EO</u> Examiner's Initials _____ Initials _____					

ADDRESS SIEMENS CORPORATION
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186 WOOD AVENUE SOUTH
ISELIN NJ 08830

TITLE METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE

FILING FEE RECEIVED \$760	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT NO. _____ for the following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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